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U.S.S.N. 10,656,986

**MAY 25 2007**

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Lu et al.

Group Art Unit: 2813

Serial No.: 10,656,986

Examiner: Doty, H.A.

Filed: 09/04/2003

In Response to Office Action

Dated: 02/07/2007

For:

**MULTIPLE EXPOSURE METHOD FOR FORMING  
PATTERNED PHOTORESIST LAYER**

Attorney Docket No.: 67,200-1145(2002-1332)

**CERTIFICATE OF MAILING OR FACSIMILE TRANSMISSION**

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Randy W. Tung

Printed Name

  
Signature4/25/07  
Date

**Please forward all correspondence to  
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U.S.S.N. 10,656,986

RESPONSE TO OFFICE ACTION

Assistant Commissioner  
for Patents  
P.O. Box 1450  
Alexandria, Va 22313-1450

Dear Sir:

In response to an Office Action mailed 02/07/2007,  
please enter the following amendments and consider the following  
remarks.